



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of:

Keum Joo LEE, et al:

Serial No. 09/955,126

Art Unit: 1746

Examiner: Michail Kornakov

Filed: September 19, 2001

Confirmation No. 8415

For: METHOD OF CLEANING
DAMAGED LAYERS AND
POLYMER RESIDUE FROM
SEMICONDUCTOR DEVICE

Atty. Docket No. 259/011

AMENDMENT UNDER 37 C.F.R. §1.111

Commissioner for Patents
P.O. Box 1450
Alexandria, Va. 22313-1450

Sir:

In response to the Office Action mailed September 11, 2003, please amend the subject application as follows: